

Notice of References Cited	Application/Control No. 10/789,448	Applicant(s)/Patent Under Reexamination TENHUNEN, JOUKO	
	Examiner Viet Vu	Art Unit 2154	Page 1 of 1

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*	B	US-6,922,568	07-2005	Nakamura, Yoshitaka	455/462
*	C	US-2006/0125927	06-2006	Watanabe, Mikio	348/211.1
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NON-PATENT DOCUMENTS

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